

## Electronic Patent Application Fee Transmittal

|                                      |   |  |  |  |
|--------------------------------------|---|--|--|--|
| Application Number:                  | 10519724  |  |  |  |
| Filing Date:                         | 28-Dec-2004   |  |  |  |
| Title of Invention:                  | Device and method for the production of chlorotrifluoride and system for etching semiconductor substrates using said device |  |  |  |
| First Named Inventor/Applicant Name: | Franz Laermer   |  |  |  |
| Filer:                               | Gerard A. Messina/Kevin Kambo   |  |  |  |
| Attorney Docket Number:              | 10191/3980  |  |  |  |

Filed as Large Entity

### U.S. National Stage under 35 USC 371 Filing Fees

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-------------|----------|----------|--------|----------------------|
|-------------|----------|----------|--------|----------------------|

Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

|                  |      |   |     |     |
|------------------|------|---|-----|-----|
| Notice of appeal | 1401 | 1 | 540 | 540 |
|------------------|------|---|-----|-----|

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

| Description                        | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|------------------------------------|----------|----------|--------|----------------------|
| Extension - 2 months with \$0 paid | 1252     | 1        | 490    | 490                  |
| <b>Miscellaneous:</b>              |          |          |        |                      |
| <b>Total in USD (\$)</b>           |          |          |        | <b>1030</b>          |